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<b>SERIAL NUMBER</b> 10/822,691	<b>FILING OR 371(c) DATE</b> 04/13/2004 <b>RULE</b>	<b>CLASS</b> 257	<b>GROUP ART UNIT</b> 2815	<b>ATTORNEY DOCKET NO.</b> OKI 419	
<b>APPLICANTS</b> Takashi Noguchi, Tokyo, JAPAN; <b>** CONTINUING DATA *****</b> <b>** FOREIGN APPLICATIONS *****</b> JAPAN 111182/2003 04/16/2003 JAPAN 100442/2004 03/30/2004 <b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 06/23/2004</b>					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged _____ Examiner's Signature _____ Initials _____		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 6	<b>TOTAL CLAIMS</b> 32	<b>INDEPENDENT CLAIMS</b> 6
<b>ADDRESS</b> RABIN & BERDO, P.C. Suite 500 1101 14th Street Washington, DC20005					
<b>TITLE</b> HEAT RADIATION STRUCTURE OF SEMICONDUCTOR DEVICE, AND MANUFACTURING METHOD THEREOF					
<b>FILING FEE RECEIVED</b> 1344	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		